

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Mirkarimi et al.

Application No.: 10/086,614

Filed: March 1, 2002

For: ION-ASSISTED DEPOSITION  
TECHNIQUES FOR THE  
PLANARIZATION OF TOPOLOGICAL  
DEFECTS

Examiner: Bashore, Alain L.

Art Unit: 1792

Conf. No.: 1932

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR CHANGE OF ATTORNEY DOCKET NUMBER**

Sir:

Please change the attorney docket number of the above-identified patent application to the following:

**From:**  
CIL-10972

**To:**  
**026505-0170P**

Please update the Patent Office records to reflect the new Attorney Docket Number. Please charge Deposit Account 50-2191 any additional charges that may be due.

Respectfully submitted,  
RUTAN & TUCKER, LLP

Date: May 15, 2008

/Thomas S. Ferrill/  
Thomas S. Ferrill  
Reg. No. 42,532

Customer No. 34284  
611 Anton Boulevard, Suite 1400  
Costa Mesa, CA 92626  
(650) 320-1500